



# **DIGITAL LASER SENSORS**

for diameter and gap measurements of 0.2 mm to 2000 mm

350 1360 1370 1380 1390 1400 1410 1420 1430 1440 1450 1460 1470 1480 1490 1500 1510 1520 1530 1 350 1560 1570 1580 1590 1600 1610 1620 1630 1640 1650 1660 1670 1680 1690 1700 1710 1720 1730 1 350 1760 1770 1780 1790 1800 1810 1820 1830 1840 1850 1860 1870 1880 1890 1900 1910 1920 1930 1 350 1960 1970 1980 1990 2690 0,1 0,2 0,3 0,4 0,5 0,6 0,7 0,8 0,9 1 2 3 4 5 6 7 8 9 10 11 12 13 14 15 16 1 30 20 30 40 50 60 70 80 90 100 110 120 130 140 150 160 170 180 190 200 210 220 230 240 250 260 270 2 30 300 310 320 330 340 350 360 370 380 390 400 410 420 430 440 450 460 470 480 490 500 510 520 53 40 550 560 570 580 590 600 610 620 630 640 650 660 670 680 690 700 710 720 730 740 750 760 780 79













## LAP METIS LASER SCAN MICROMETER.



#### HIGHLIGHTS.

- high measuring frequency:800 Hz, 1.6 kHz optional
- high resolution: from 5 nm
- detection and simultaneous measurement of up to 10 edges
- synchronized measurement of various sensors
- measurement of complex profiles with multi-axes systems

**NON-CONTACT MEASUREMENT:** LAP METIS laser sensors measure cross-section and gap without touching the surface. Mechanical micrometers, that may scratch the material, are no longer necessary. There is no wear or tear, neither on the object nor on the sensor. No operator influence affects the measurement.

**FAST MEASUREMENT:** Laser scan micrometers may check 100% in the production line. At 800 values per second or even 1600 values per second. No more time consuming samples and offline checks. Instead of momentary images you get errors or tendencies displayed during production, enabeling you to react before crop is produced.

**PRECISE MEASUREMENT:** LAP METIS measure at repeatabilities of 2 µm to 8 µm (depending on model) due to calibration and linearisation for every single mirror of the rotating prism. Transparent material can be measured as well as shiny metal or soft and sticky rubber.

**SYNCHRONIZED MEASUREMENT:** Sensors are synchronized in multi-axes measurement. Even at high production speeds, there is no mismatch or offset between measurement values in transport direction.

**FLEXIBLE MEASUREMENT:** LAP METIS measure precisely up to 10 edges (transitions object - space or space - object). Multi-axes systems also measure non-round profiles as square or polygonal profiles.

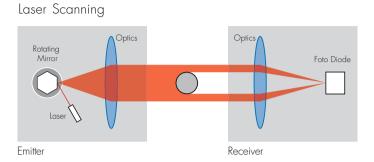
## SAVE TIME, SAVE MATERIAL, SAVE MONEY.

LAP METIS laser scan micrometers offer 100%-check for many measuring tasks at higher material throughput. They prevent crop and let you prove quality - for your own production and for your customers.

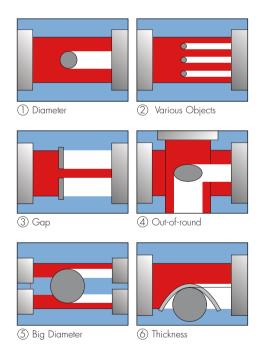
## SOLUTIONS FOR YOUR COMPANY.

#### THE OPERATING PRINCIPLE.

Laser sensors of LAP METIS series work by laser scanning. One sensor consists of emitter and receiver. In the emitter, the laser beam of a diode laser is reflected by a rotating prism in the focus of a precision lens. The lens changes angular beams to a parallel beam that traverses the measuring range cyclical (virtual laser band). The



moving beam is focussed on a photo diode in the receiver. If there is an object between emitter and receiver, the photo diode gets no laser light for a certain period. This period defines the dimension of the object.



## **SOLUTIONS AND APPLICATIONS.**

Single systems measure diameter (1), position or displacement of various objects (2) or gaps (3), e. g. roll gap.

Two sensors, positionned at 90°, may measure out-of-round (4) or define the position of an object on a plane. For diameters that exceed the measuring range of a single sensor, two sensors with fixed distance may be used - the "big diameter" setting (5). You add upper and lower displacement value with the known distance of the sensors to get the final diameter.

Multi-axes systems offer measurement of convex polygons. For width or straightness measurement, three sensors at fixed intervals on one side and one opposite sensor are combined. You may measure thickness of strips against a roller by using one or two sensors to measure on the roler and one or several sensors to measure on the strip (6). This way, changes in roller diameter and excentricity are compensated for.

# SYSTEM INTEGRATION

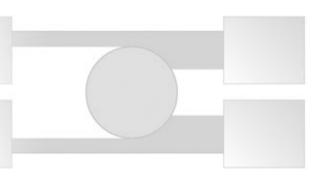
## THE LAP MEASURING SYSTEM.

LAP sensors reach optimum performance, when measuring data is transmitted and evaluated via RS485. LAP developped "SynchroNet" protocol for high data transmission bandwidth, little protocol overhead, highest flexibility and a guaranteed future. All LAP sensors, the Digital Control Unit "DCU", interfaces to Ethernet, Profibus DP and RS232 as well as digital or analog I/O-modules may participate on this bus.

Data evaluation and visualisation takes place on an IPC, PLC or by DCU. DCU offers simple mathematical ANTARIS RS 485 Interface PROFIBUS DP Encoder Modules

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operations and visualisation directly at the production line. Measurement values may be transferred to big displays. Please see the related brochures for details on further sensors, DCU and products with RS485/SynchroNet connection.



### **EASY INTEGRATION.**

LAP METIS sensors are equipped with:

RS485 serial interface

Additional interface modules are available for:

- RS232 ASCII
- Ethernet UDP
- Profibus DP

### DATA ACQUISITION AND SOFTWARE.

LAP offers standard software for data collection, visualization and documentation. For archiving it can be provided with a SQL database, or it can be linked to existing customer databases.



# **TECHNICAL DATA.**

# **EXAMPLES.**

	METIS 45	METIS 90	METIS 120	METIS 150	METIS 180
Measuring range	0.2 - 45 mm	0.5 - 90 mm	1 - 120 mm	1 - 150 mm	1 - 180 mm
Resolution	5.4 nm	10.8 nm	14.4 nm	18 nm	22 nm
Repeatability	± 2 μm	± 3 µm	± 4 µm	± 6 µm	± 8 µm
Linearity	± 8 µm	± 15 µm	± 20 μm	± 25 µm	± 30 µm
Measuring field	45 x 45 mm	90 x 90 mm	120 x120 mm	150 x150 mm	180x180 mm
Standard Distance Emitter-Receiver	300 mm	650 mm	840 mm	840 mm	800 mm
Weight	1.5 kg	2.6 kg	5.3 kg	8.9 kg	11.5 kg
Dimensions (W×H×D, mm) Emitter Receiver	135×75×60 135×75×60	165×102×61 165×102×61	235×164×62 235×164×62	300×180×85 270×180×85	336.5×220×85 197×220×85

# **GENERAL DATA.**

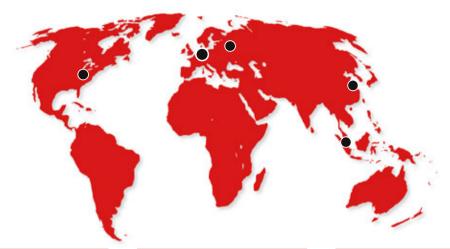
Measuring principle	Laser scanning		
Laser type, wavelength	Diode 650 nm (red)		
Laser power	≤ 1 mW		
Laser class	2		
Measuring frequency	800 Hz, optional 1600 Hz		
Interface	RS485, up to 1.8 MBaud		
Power supply	24 VDC ± 20 %		
Consumption	< 500 mA (per sensor pair)		
Enclosure rating	IP 65		
Operating conditions	0 - 45 °C / 35 - 85 % rel. humidity, non-condensing		











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